

INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(Not for submission under 37 CFR 1.99)</i>	Application Number		10816385	
	Filing Date		2004-04-01	
	First Named Inventor		Feng-Wen Sun	
	Art Unit		2461	
	Examiner Name		HAILU, Kibrom T.	
	Attorney Docket Number		PD-203051	

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1	Chinese Office Action dated 10/23/2009 in Chinese Patent Application No. 200410049082.5 filed 06/11/2004 by Feng-Wen Sun et al.	<input type="checkbox"/>
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